



Attorney's Docket No.: 13454-018001 / SOCI 0236 PUS

AF/3749

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Faykosh et al.

Art Unit : 3749

Serial No. : 09/931,470

Examiner : Karla A. Moore

Filed : August 16, 2001

Title : CHEMICAL VAPOR DEPOSITION SYSTEM

MAIL STOP AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF JULY 30, 2003

Please amend the above-identified application as follows:

RECEIVED
OCT 03 2003
TECHNOLOGY CENTER R3700